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FIG.1

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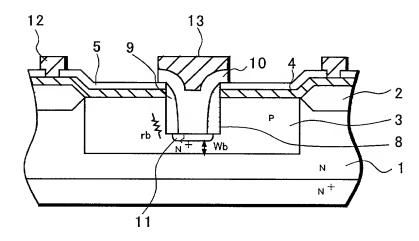
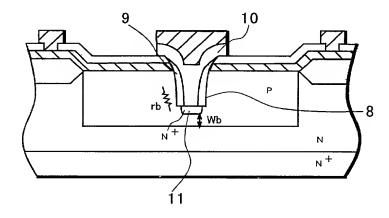


FIG.2



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FIG.3

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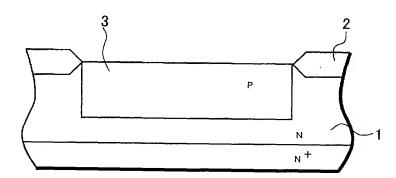
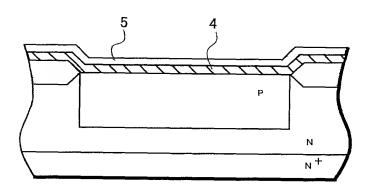


FIG.4



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FIG.5A

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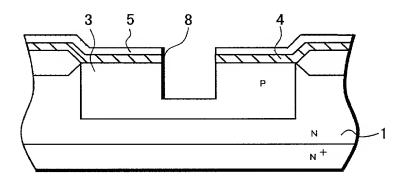
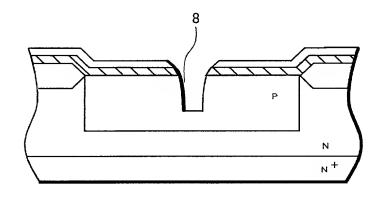


FIG.5B



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FIG.6

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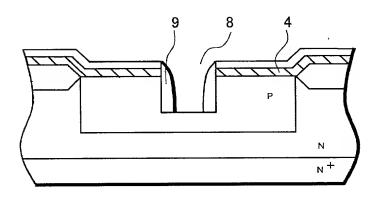
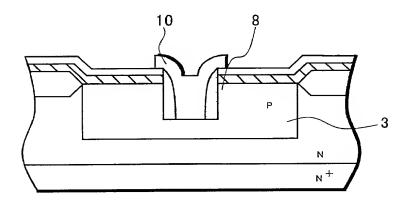


FIG.7



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FIG.8

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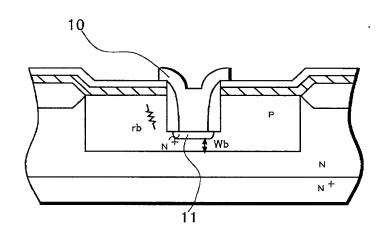
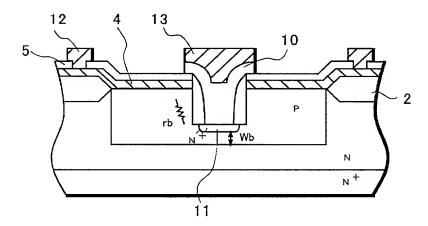


FIG.9



METHOD THEREOF

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FIG.10

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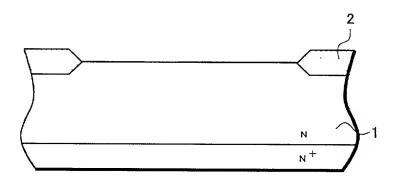
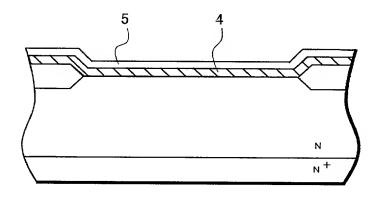


FIG.11



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FIG.12A

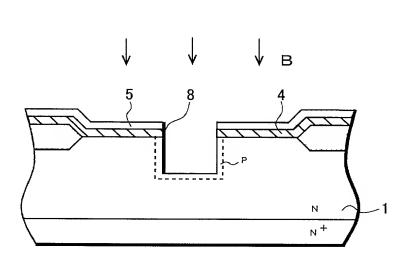
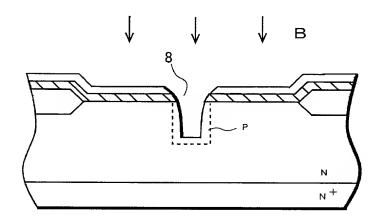


FIG.12B



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FIG.13

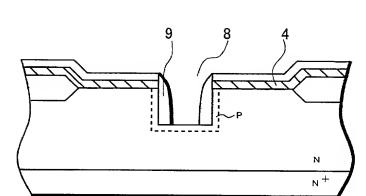
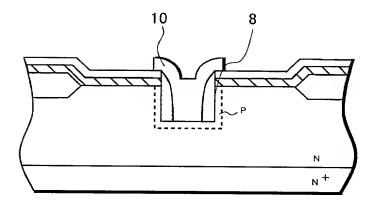


FIG.14



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FIG.15

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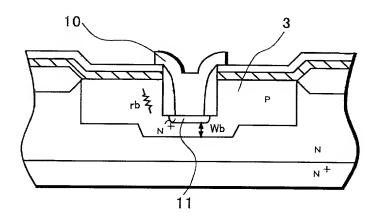
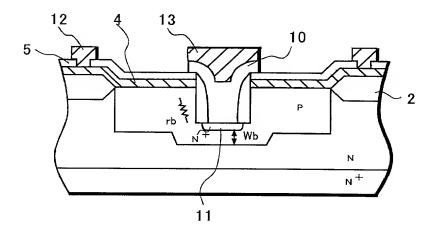


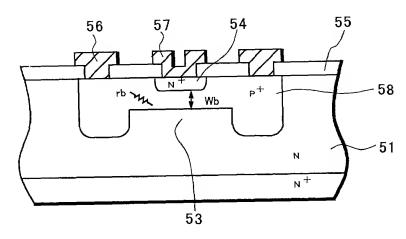
FIG.16



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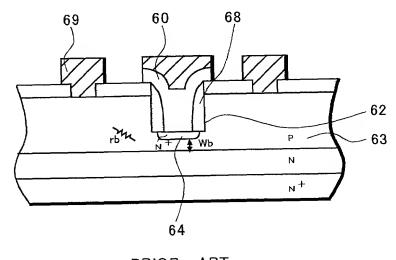
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FIG.17



PRIOR ART

**FIG.18** 



PRIOR ART